

Electronic Acknowledgement Receipt

EFS ID:	2491167
Application Number:	10689617
International Application Number:	
Confirmation Number:	4799
Title of Invention:	Method for cleaning plasma etching apparatus, method for plasma etching, and method for manufacturing semiconductor device
First Named Inventor/Applicant Name:	Satoru Okamoto
Customer Number:	26171
Filer:	Diana DiBerardino/Arlene Yates
Filer Authorized By:	Diana DiBerardino
Attorney Docket Number:	12732-170001
Receipt Date:	20-NOV-2007
Filing Date:	22-OCT-2003
Time Stamp:	12:28:52
Application Type:	Utility under 35 USC 111(a)

Payment information:

Submitted with Payment	yes
Payment Type	Deposit Account
Payment was successfully received in RAM	\$ 180
RAM confirmation Number	8796
Deposit Account	061050
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File Listing:					
Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
1	Information Disclosure Statement (IDS) Filed	12732170001IDS.pdf	338253	no	3
			69db6e1cf73afb837285ae1d383391a1c0d247d4		
Warnings:					
Information:					
This is not an USPTO supplied IDS fillable form					
2		12732170001refs.pdf	3517729	yes	51
			7471941533385e907ea75c97dcd14072490fb5b3		
	Multipart Description/PDF files in .zip description				
	Document Description		Start	End	
	Foreign Reference		1	5	
	Foreign Reference		6	8	
	Foreign Reference		9	19	
	Foreign Reference		20	51	
Warnings:					
Information:					
3	Fee Worksheet (PTO-06)	fee-info.pdf	8222	no	2
			6edf4f870c18d4b9d12254293389eb892ad33e66		
Warnings:					
Information:					
Total Files Size (in bytes):			3864204		

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.